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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hideomi KOINUMA et al.**

Art Unit: **1763**

Application Number: **10/528,265**

Examiner: **Jeffrie R. Lund**

Filed: **March 17, 2005**

Confirmation Number: **2280**

For: **MASKING MECHANISM FOR FILM FORMING APPARATUS**

Attorney Docket Number: **052267**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop: Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

December 26, 2007

Sir:

This paper is filed in response to the Office Action dated September 26, 2007.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.